

IN THE UNITED STATES
PATENT AND TRADEMARK OFFICE

PATENT APPLICATION



Applicant: Chou, et al. Case: 5930/ALRT/CPI/L/B/PJS
Serial No.: Not yet assigned Filed: Herewith
Examiner: Not yet assigned Group Art Unit: Not yet assigned

Title: METHOD OF TISIN DEPOSITION USING A CHEMICAL
VAPOR DEPOSITION PROCESS

ASSISTANT COMMISSIONER FOR PATENTS
Washington, DC 20231

S I R:

Disclosure Statement Under 37 C.F.R. 1.56 and 1.98

Pursuant to 37 C.F.R. 1.56, the documents (copies enclosed) listed on Form PTO-1449, submitted herewith, are disclosed. Under Rule 37 C.F.R. 1.98(a), the Applicants submit that no specific comments are necessary for any of the cited foreign language publications having an enclosed English language translation or abstract.

Respectfully submitted,

12/21/01
Date

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